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2771-696

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:)	Docket No.: 2771-696
Applicants: HENDRIX, Bryan C. et al.)	Conf. No.: 6889
Application No.: 10/803,750)	Art Unit: 1762
Date Filed: March 18, 2004)	Examiner: Fuller, Eric B.
Title: CHEMICAL VAPOR DEPOSITION OF HIGH CONDUCTIVITY, ADHERENT THIN FILMS OF RUTHENIUM)	Customer No.: 25559

FACSIMILE TRANSMISSION CERTIFICATE

ATTN: Examiner Eric Fuller

Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, and transmitted on October 2, 2006, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

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Number of Pages

Steven J. Hultquist

September 29, 2006

Date

**RESPONSE TO JUNE 29, 2006 OFFICE ACTION IN U.S. PATENT APPLICATION NO.
10/803,750**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This responds to the June 29, 2006 Office Action in the above-identified application. Please enter the following amendment and remarks, wherein the **Amendments to the Claims** begin on page 2, and the **Remarks** begin on page 14.